

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80665

Kazuo FUJITA

Appln. No.: 10/811,872

Group Art Unit: 1796

Confirmation No.: 2481

Examiner: Callie E. SHOSHO

Filed: March 30, 2004

For: SILICA-CONTAINING COATING COMPOSITION FOR FORMING FILMS AND  
METHOD FOR FORMING SILICA-CONTAINING FILMS

**STATEMENT UNDER 37 C.F.R. § 1.97(e)**

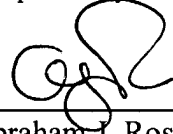
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,



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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: October 16, 2007